

ATTORNEY DOCKET NO. 4591-366
CLIENT REF. NO. IC12242-USIN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Jeong-Min CHOI and Tae-Hong NA
Serial No.: 10/750,983 Examiner: Erden, Fazli
Filing Date: January 2, 2004 Group Art Unit: 2826
Confirmation No.: 5470
Title: SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND METHOD OF
FABRICATING THE SAME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
CENTRAL FAX CENTERINFORMATION DISCLOSURE STATEMENT

JAN 24 2005

Sir:

This Information Disclosure Statement is submitted:

- ☐ under 37 CFR 1.97 (b); or
(Within three months of filing national application; or date of entry of International application;
or before mailing date of first office action on the merits; or before the mailing of a first Office
Action after the filing of a request for continued examination under §1.114; whichever occurs
last)
- ☒ under 37 CFR 1.97 (c) together with either a:
☒ Statement under 37 CFR 1.97 (e), or
☐ a \$180 fee under 37 CFR 1.17 (p); or
(After mailing of first Office Action, but prior to Notice of Allowance or Final Office Action)
- ☐ under 37 CFR 1.97 (d) together with:
☐ Statement under 37 CFR 1.97 (e), and
☐ a \$180.00 fee set forth in 37 CFR 1.17 (p).
(Filed after final action or notice of allowance, whichever occurs first, but before payment of
the issue fee)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with
copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s)
may be material to the examination of this application and for which there may be a duty to disclose in accordance
with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A
duplicate copy of this sheet is enclosed.

Customer No. 20575

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

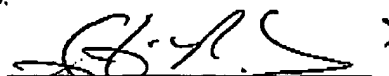


Hosoon Lee

Limited Recognition Under 37 CFR § 10.9(b)

MARGER JOHNSON & McCOLLOM, P.C.
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503-222-3613

I hereby certify that this correspondence is being transmitted to the U.S.
Patent and Trademark Office via facsimile number (703) 872-9306 on
January 24, 2005.


Stormi R. Davis

PATENT APPLICATION

Atty. Docket No.: 4591-366
Applicant: Jeong-Min CHOI and Tae-Hong HA
Filing Date: January 2, 2004

Serial No.: 10/750,983
Group: 2826

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)RECEIVED
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JAN 24 2005

U.S. PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
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FOREIGN PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
.....	05-304108	Nov. 16, 93	Japan	Miyamoto Takaaki

OTHER DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English language abstract of Japanese Publication No. 05-304108

Examiner: _____

Date Considered: _____

PATENT APPLICATION
Attorney's Docket No.: 4591-366
Client Ref. No.: IC12242-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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STATEMENT ON FILING INFORMATION DISCLOSURE STATEMENT
(37 CFR 1.97(e))

I, Todd J. Iverson, the person signing below state that:

each item of information contained in the Information Disclosure Statement submitted herewith was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement

no information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing this Statement after making reasonable inquiry, was known to any individual designated in § 1.56(c) more than three months prior to the filing of the Statement.

Applicant respectfully requests consideration of the accompanying Information Disclosure Statement.

The person making this Statement is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

Hosoon Lee
Limited Recognition Under 37 CFR § 10.9(b)

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Stormi R. Davis